## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
	: Examiner: Unassigned
Takehiko IWANAGA et al.	)
	: Group Art Unit: Unassigned
Application No.: 10/662,471	)
	:
Filed: September 16, 2003	)
	;
For: POWER MONITORING UNIT, CONTROL	) December 2, 2003
METHOD THEREFOR, AND EXPOSURE	:
APPARATUS	)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## SUBMISSION OF PRIORITY DOCUMENT

Sir:

In support of Applicants' claim for priority under 35 U.S.C. § 119, enclosed is one certified copy of the following foreign application:

> 2002-278113, filed September 24, 2002. **JAPAN**

Applicants' undersigned attorney may be reached in our Washington, D.C., office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

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SEW/eab



別紙添付の書類に記載されている事項は下記の出願書類に記載されている事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed ith this Office.

出願年月日 Date of Application:

2002年 9月24日

出願番号 Application Number:

特願2002-278113

ST. 10/C]:

[ J P 2 0 0 2 - 2 7 8 1 1 3 ]

: 願 人 oplicant(s):

キヤノン株式会社



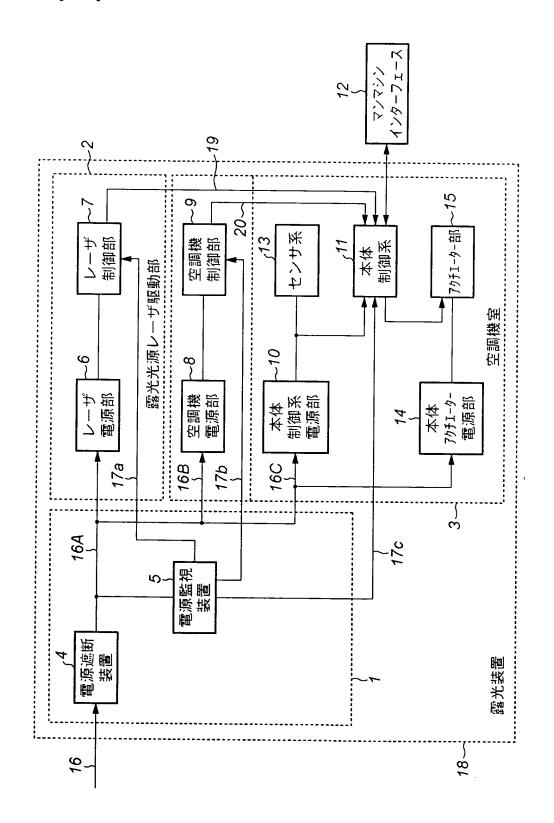
特許庁長官 Commissioner, Japan Patent Office 2003年10月14日

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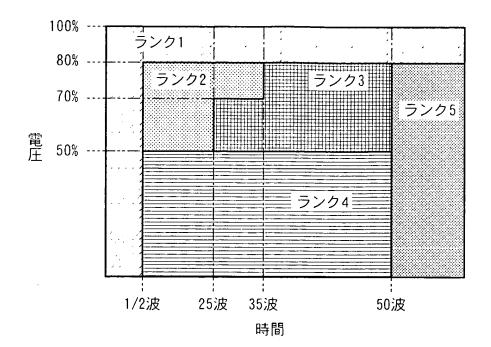


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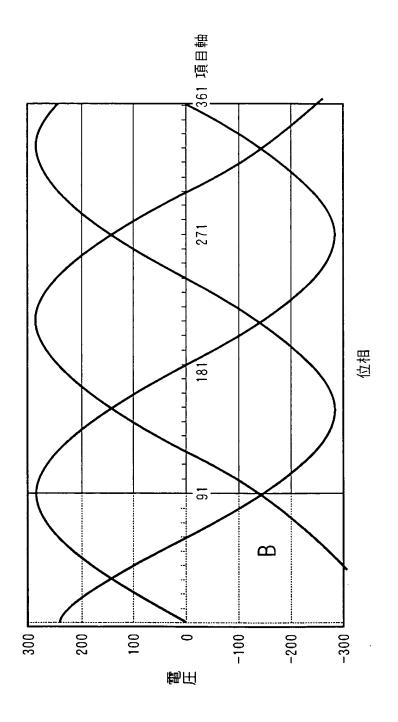
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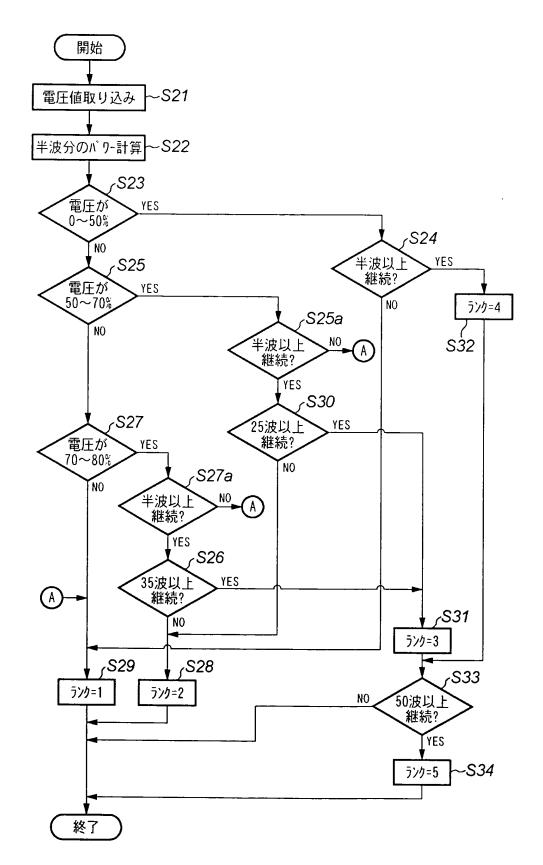
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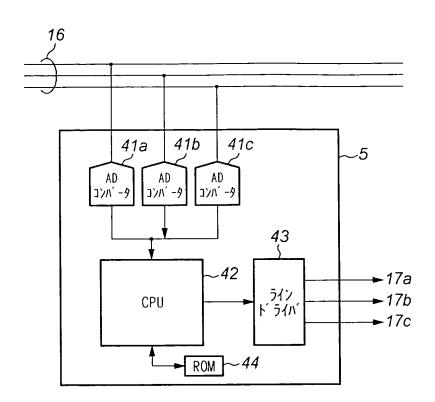
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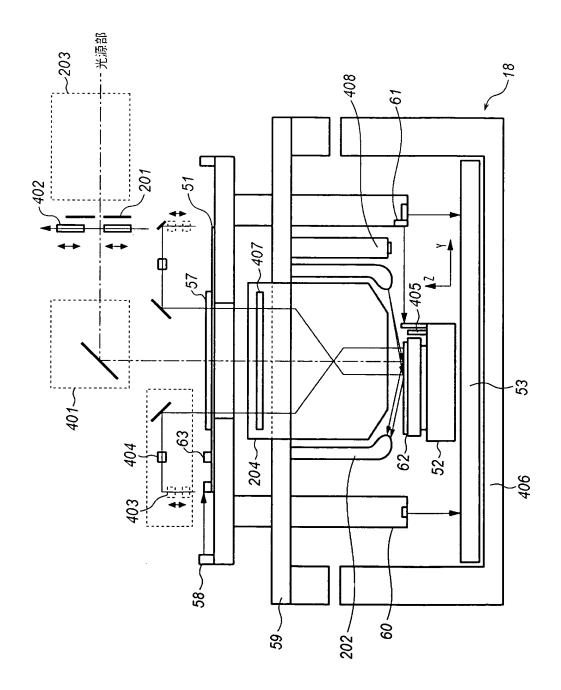
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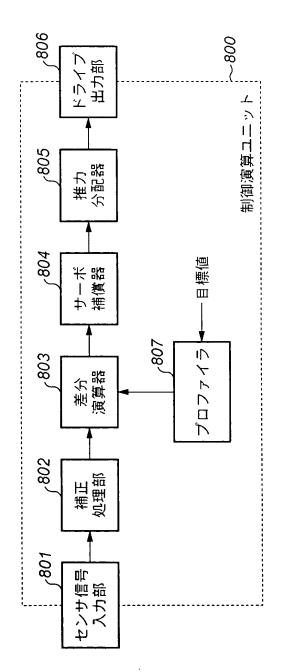
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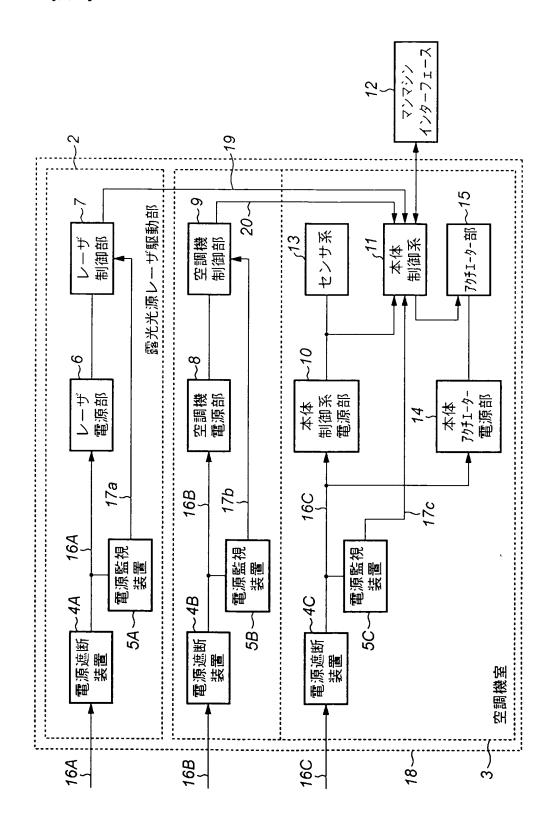
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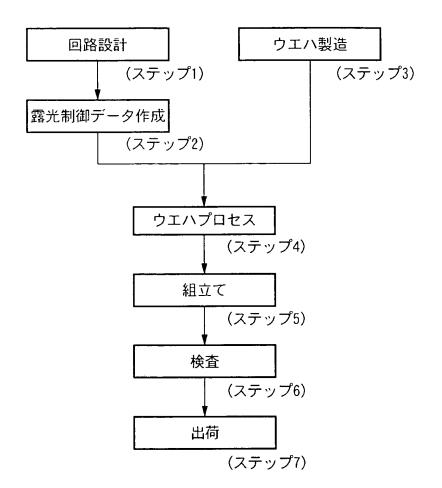
【図7】



【図8】



[図9]



【図10】

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